

**Search Notes**

Application/Control No.

10/650,601

Examiner

José R. Díaz

Applicant(s)/Patent under  
Reexamination

LIN, SHI-CHI

Art Unit

2815

**SEARCHED**

Class	Subclass	Date	Examiner
438	409, 429, 431, 433, 4 47, 450	2/6/2006	JRD

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
438	409	2/6/2006	JRD
438/429, 431, 433, 447, 450		2/6/2006	JRD

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Text search EAs. See search printout.	2/6/2006	JRD